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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of

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Chul-Hwan CHOI et al. : Group Art Unit 3652

Serial No. 10/050,104 : Examiner T. Brahan

Filed January 18, 2002 :

SELF-CONTAINED SEMICONDUCTOR DEVICE MANUFACTURING EQUIPMENT HAVING COMPACT ARRANGEMENT OF LOAD-LOCK AND PROCESSING CHAMBERS

## REQUEST FOR RECONSIDERATION

U.S. Patent and Trademark Office Customer Service Window, Mail Stop AF Randolph Building 401 Dulany Street Alexandria VA 22314

Sir:

In response to the Office action of May 19, 2005, the following remarks are submitted.

## **Summary of Claimed Invention**

Pending claim 13 sets forth semiconductor manufacturing equipment in which a number of the process chambers 32a (or 32b in the embodiment of FIG. 4) and a number of corresponding load lock chambers 34a (or 34b) are disposed side-by-side as oriented parallel to one another at each of first and second sides of the transfer chamber 30a. Also, these first and second sides of the transfer chamber 30a, at which